

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF:      Peyman Hadizad  
FILED:                      Concurrently Herewith  
FOR:                         METHOD OF MAKING A VERTICAL COMPOUND  
                              SEMICONDUCTOR FIELD EFFECT  
                              TRANSISTOR DEVICE  
Date:                        7/18/2003

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**DISCLOSURE STATEMENT UNDER 37 C.F.R. 1.56**

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231

SIR:

It is respectfully requested that the prior art listed on FORM PTO-1449 be considered in the examination of the subject application and made of record therein. A copy of the listed prior art is enclosed herewith.

No representation is made or intended that the listed prior art enclosed herewith is material to patentability of the subject patent application.

No representation is made or intended that a search has been made or that no better prior art than that listed is available.

Respectfully submitted,  
Peyman Hadizad



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Form PTO-1449								ATTY. DOCKET NO.	SERIAL NO.
<b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b> <small>(Use Several Sheets If Necessary)</small>								Ons00505	
								APPLICANT <b>Peyman Hadizad</b>	
								FILING DATE <b>CONCURRENTLY</b>	GROUP

REFERENCE DESIGNATION                    U.S. PATENT DOCUMENTS

Examiner Initial	Document Number								Date	Name	Class	Sub-Class	Filing date (If appropriate)
AA	6	3	5	6	0	5	9		3/12/2002	Yu	G05F	1/613	
AB	5	6	1	0	0	8	5		3/11/1997	Yuan et al	H01L	21/265	
AC	5	2	3	1	0	3	7		7/27/1993	Yuan et al	H01L	21/44	
AD	5	2	6	2	2	9	6		4/14/1981	Shealy et al	H01L	29/06	
AE													
AF													
AG													
AH													
AI													
AJ													
AK													
AL													
AM													

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document #								Date	Country	Class/subclass	Translation Yes - N	
	AN	E P	0	8	7	4	3	9	4	10/28/19 98	EPO	H01L	21/337	
	AO													
	AP													
	AQ													
	AR													

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AS			
AT			
AU			
AV			
AW			

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.